



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 9516**  
Norio KIMURA et al. : Docket No. 2003-0865  
Serial No. 10/601,789 : Group Art Unit 3723  
Filed June 24, 2003 : Examiner Hadi Shakeri

APPARATUS FOR POLISHING A  
SUBSTRATE

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**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of March 31, 2004, kindly amend the above-referenced U.S. patent application as follows:

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975